

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Prior Application: N. TAKAHASHI et al
Serial No. 10/453,606
Filed: June 4, 2003

Group Art Unit: 2813
Examiner: C. Chaudhari
For: A METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE AND A
SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

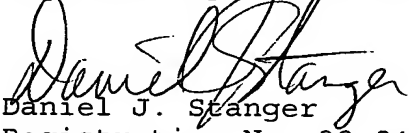
February 24, 2004

Sir:

In accordance with the duty of disclosure, Applicants inform the Examiner of the documents cited during prosecution of the parent application, USSN 10/453,606.

Applicants request the Examiner to initial and return a copy of the attached PTO-1449 form to indicate that the references have been considered.

Respectfully submitted,


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Date: February 24, 2004

FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. H-1018-03		SERIAL NO.	
LIST OF DOCUMENTS CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT N. TAKAHASHI et al			
				FILING DATE 02/24/04		GROUP 2813	
U.S. PATENT DOCUMENTS							
* EXAMINER INITIAL		DOCUMENT	DATE	NAME	CLASS	SUBCLASS	FILING DATE (If Appropriate)
	AA	5,776,798	07/07/98	Quan et al			
	AB	5,904,502	05/18/99	Ference			
	AC	6,329,220	12/2001	Bolken et al			
	AD	6,245,595	06/2001	Nguyen et al			
	AE	6,358,776	03/2002	Takehara et al			
	AF	6,346,433	02/2002	Maeda et al			
	AG	5,914,531	06/1999	Tsunoda et al			
	AH	6,228,684	05/2001	Maruyama			
	AI	6,287,895	09/2001	Sato			
	AJ	6,333,564	12/2001	Katoh et al			
	AK	2001/ 0003049	05/1998	Fukasawa et al			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
	AL	7-321248	12/08/95	Japan			<input type="checkbox"/> <input type="checkbox"/>
	AM	10-256286	09/25/98	Japan			<input type="checkbox"/> <input type="checkbox"/>
	AN	10-244556	09/14/98	Japan			<input type="checkbox"/> <input type="checkbox"/>
	AO	11-16930	01/22/99	Japan			<input type="checkbox"/> <input type="checkbox"/>
	AP	2000- 12578	01/14/00	Japan			<input type="checkbox"/> <input type="checkbox"/>
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	AR	English-Language Translation of JP 2000-138246, Published May 16, 2000,					
		Patent Abstracts of Japan.					
	AS						
	AT						
EXAMINER				DATE CONSIDERED			

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U.S. PATENT DOCUMENTS							
* EXAMINER INITIAL		DOCUMENT	DATE	NAME	CLASS	SUBCLASS	FILING DATE (If Appropriate)
	AA	2002/ 0089062	07/2002	Saran et al			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
	AL	2000- 138246	05/16/00	Japan			<input type="checkbox"/> <input type="checkbox"/>
	AM	0 971 401	01/12/00	Europe			<input type="checkbox"/> <input type="checkbox"/>
	AN	0 853 337	07/15/98	Europe			<input type="checkbox"/> <input type="checkbox"/>
	AO						<input type="checkbox"/> <input type="checkbox"/>
	AP						<input type="checkbox"/> <input type="checkbox"/>
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	AR						
	AS						
	AT						
EXAMINER				DATE CONSIDERED			